Docket No.: 56937-044



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

C. Moon

In re Application of

Masahiro ONO, et al.

Serial No.: 10/046,265

Filed: January 16, 2002

Group Art Unit: 2829

Examiner: GEYER, Scott B.

PHOTO-SEMICONDUCTOR MODULE AND METHOD FOR MANUFACTURING

THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

For:

Noting the Office Action of May 21, 2003 wherein restriction has been required, Applicant(s) hereby elect Group I (claims 1-15, drawn to a photo-semiconductor module) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Michael E. Fogarty Registration No. 36,139

600 13th Street, N.W. Washington, DC 20005-3096 (202) 756-8000 MEF:men Facsimile: (202) 756-8087

Date: June 13, 2003